



Docket No.: 244747US0X

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313



ATTORNEYS AT LAW

RE: Application Serial No.: 10/694,890
Applicants: Kazuo NISHIMOTO, et al.
Filing Date: October 29, 2003
For: AQUEOUS DISPERSION FOR CHEMICAL
MECHANICAL POLISHING, CHEMICAL
MECHANICAL POLISHING PROCESS,
PRODUCTION PROCESS OF SEMICONDUCTOR
DEVICE AND MATERIAL FOR PREPARING AN
AQUEOUS DISPERSION FOR CHEMICAL
MECHANICAL POLISHING
Group Art Unit: 1755
Examiner: MARCHESCHI, M.A.

SIR:

Attached hereto for filing are the following papers:

Response to Restriction Requirement

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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DOCKET NO: 244747US0X



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KAZUO NISHIMOTO, ET AL. : EXAMINER: MARCHESCHI, M. A.
SERIAL NO: 10/694,890 :
FILED: OCTOBER 29, 2003 : GROUP ART UNIT: 1755
FOR: AQUEOUS DISPERSION FOR :
CHEMICAL MECHANICAL POLISHING,
CHEMICAL MECHANICAL POLISHING
PROCESS, PRODUCTION PROCESS OF
SEMICONDUCTOR DEVICE AND
MATERIAL FOR PREPARING AN
AQUEOUS DISPERSION FOR
CHEMICAL MECHANICAL POLISHING

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

This is responsive to the Restriction Requirement mailed October 18, 2004.

Applicants elect, with traverse, the claims of Group II, Claims 7-10 and 16-19, for examination.

Remarks/Arguments begin on page 2 of this paper.